						U	MB No. 06	21-00
			Applicant: Docket:	Grah et al D-43583-01		Serial ?	No.:10/72:	5,209
INFORMATION DISCLOSURE			Filed:	December 1, 2003			·	
			Art Unit:	1711				
	દે		Examiner:	S. McClendon				
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Patent and Trademark Office. U.S. Department of Commerce

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INFORMATION DISCLOSURE				Applicant: Docket: Filed: Art Unit: Examiner:	Grah et al D-43583-01 December 1, 2003 1711 S. McClendon		Serial 1	No.:10/72	5,209
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OMB No. 0651-0011										
				Applicant: Grah et al			Serial No.:10/725,209			
				Docket:	D-43583-01				,	
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· INFORMATION DISCLOSURE CITATION			Applicant: Docket: Filed: Art Unit: Examiner:	Grah et al D-43583-01 December 1, 2003 1711 S. McClendon	OMB No. 0651-0011 Serial No.:10/725,209			
			Title: Method	of Increasing the Gas T	ransmiss	ion Rate	of a Film	
			Fifth Supplemental IDS					
			U.S. PATENT	DOCUMENTS				
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SMc		US 5,691,101	11-1997	Ushirogouchi et al	<b>_</b>			
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